Catalog of Postgraduate Programs and Curricula

Curriculum for MPhil(AME) (For students admitted in 2010-11)

Program Requirements for Master of Philosophy (MPhil) Program in Advanced Materials Engineering

Credits

1. To complete **at least 15 credits** of postgraduate coursework (excluding LANG 501), of which 12 credits must be from courses in disciplines related to each student's fields of research, including 9 credits from the following core curriculum:

CENG	540	Advanced Transport Phenomena
CENG	551	Processing of Polymers and Polymer Composites
CENG	584	Nanomaterials for Chemical Engineering Applications
CIVL	524	Advanced Concrete Technology
CIVL	525	Renovation Engineering
CIVL	533	Advanced Mechanics of Materials
IELM	526	Design and Analysis of Engineering Experiments
IELM	531	Six Sigma Management Techniques
MECH	501	Foundation of Solid Mechanics
MECH	504	Nanoscale Thin Films and Nano-Structure Materials
MECH	505	Fracture of Polymers
MECH	541	Advanced Mechanical Behaviour of Materials
MECH	543	Thermodynamics and Kinetics of Materials
MECH	548	Nanocomposite Science and Technology
MECH	593	Finite Element Methods

2. Students are required to complete 3 credits of extra-disciplinary common course(s) at 500-level designed and offered by the Fok Ying Tung Graduate School.

Postgraduate Seminar

- 1. To attend a research seminar course in any of the SENG departments (e.g. CENG 680, CIVL 680, CIVL 681, MECH 609) for 1 semester when they are studying in Clear Water Bay campus.
- 2. To register an attendance rate of at least 50% in one Nansha Campus Seminar Series when they are studying in Nansha.
- 3. To make presentation at least once in a seminar in the Nansha Campus Seminar Series.

Language Requirements

Students must attend and pass LANG 501 *Postgraduate English for Academic Purposes*. *The 1 credit earned from LANG 501 cannot be counted toward the credit requirements.*

Research and MPhil Thesis Examination

- 1. To conduct research and enroll in FYTG 699 MPhil Thesis Research; and
- 2. To defend the MPhil thesis successfully.